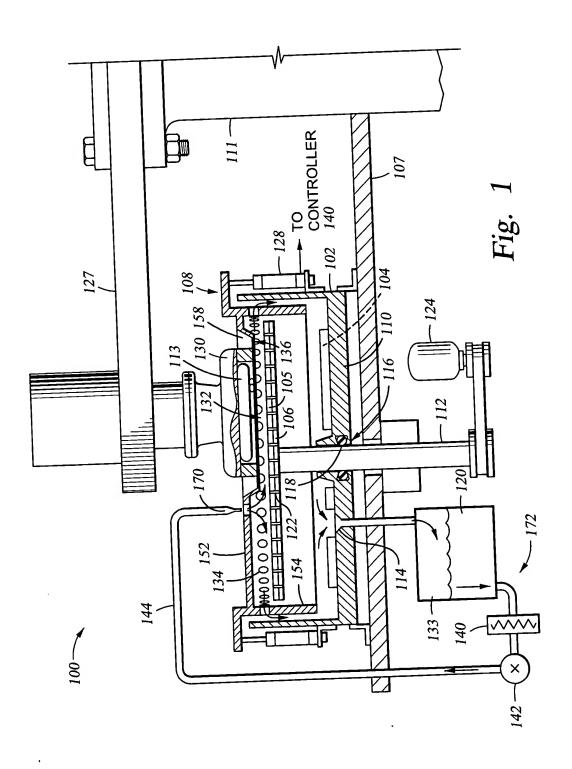
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U.S. Serial No.: Unknown Conf. No.: Unknown
June 30, 2003
Title: AN EFFECTIVE METHOD TO IMPROVE SURFACE
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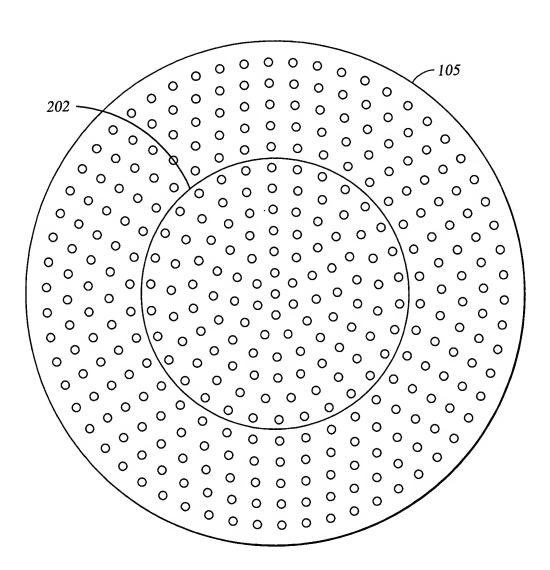


Fig. 2

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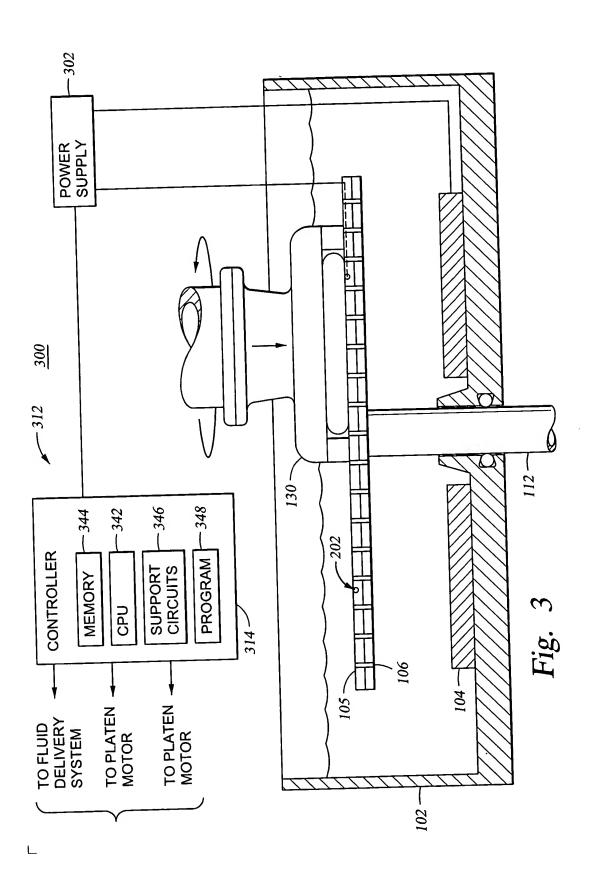
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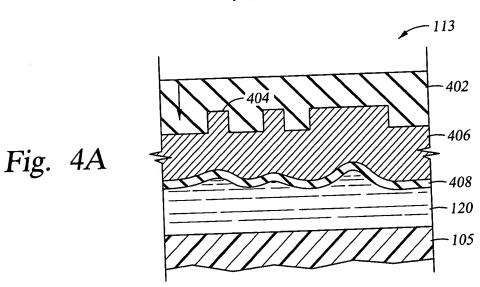
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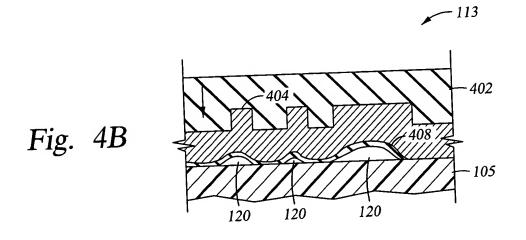
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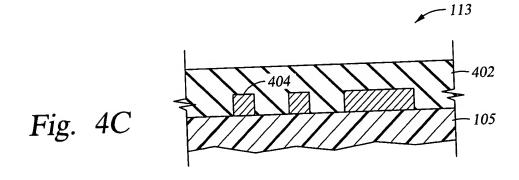
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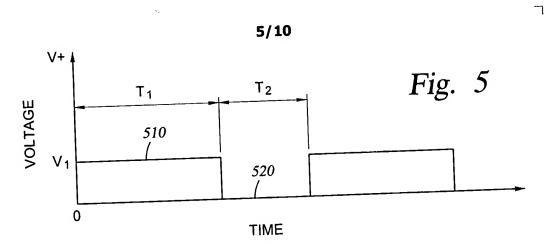


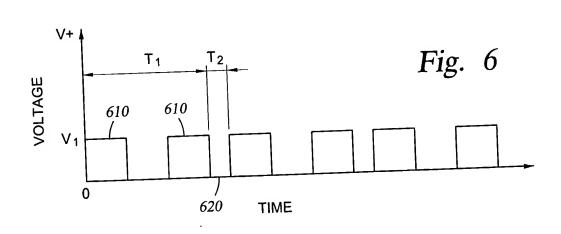


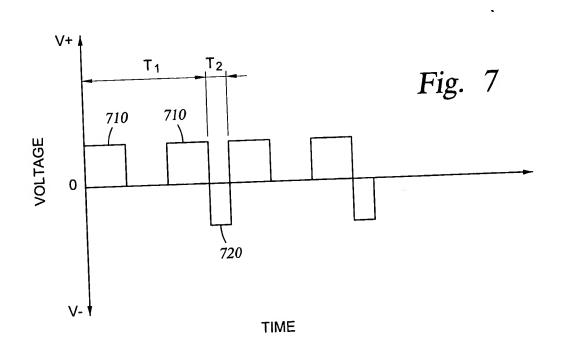


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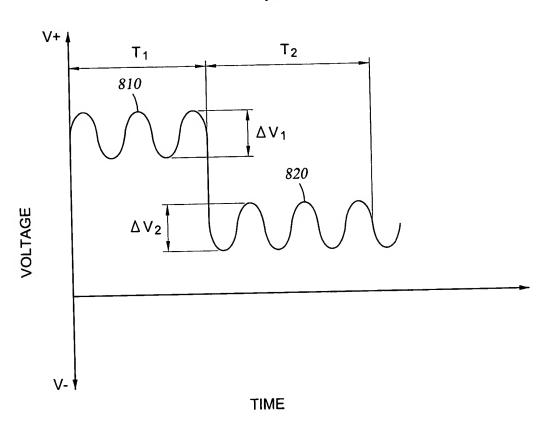


Fig. 8

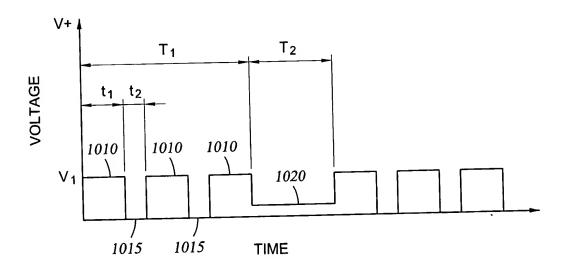


Fig. 10

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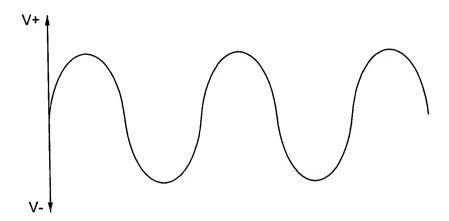


Fig. 9A

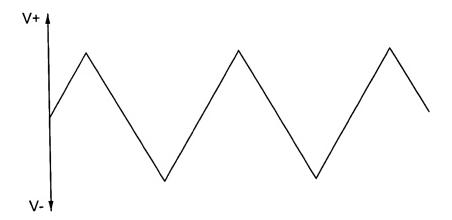


Fig. 9B

AMAT/6877/ALRT/CMP/CMP/RKK Unknown Conf. No.: Unknown June 30, 2003 Atty Dkt. No.: U.S. Serial No.: Filed:

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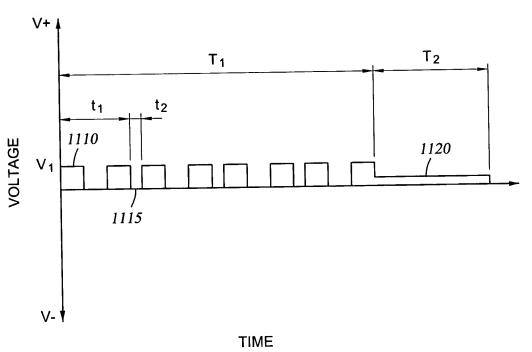


Fig. 11

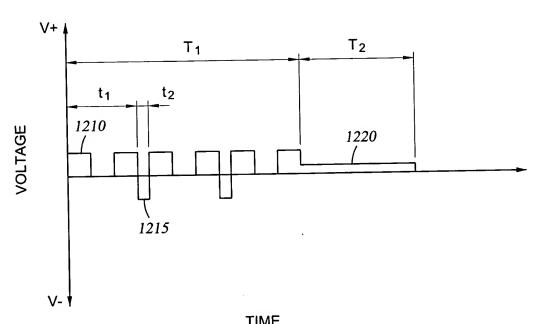
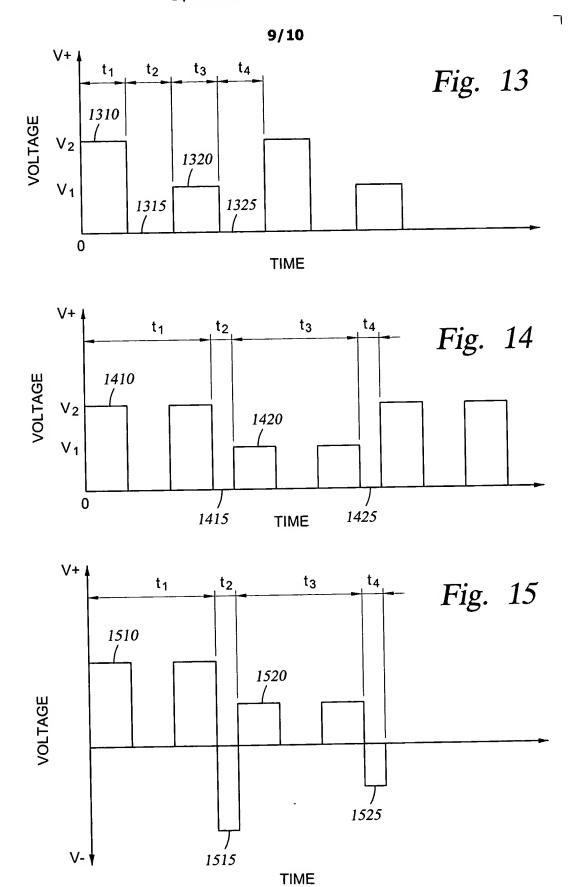


Fig. 12

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